

LIST OF PATENTS AND PUBLICATIONS FOR APPLICANTS INFORMATION DISCLOSURE STATEMENT		ATTY. DOCKET NO. FIS920020214US1	SERIAL NO. 10/605,610
		Conf.# 2609	
		APPLICANT: Donald J. Delehanty et al.	
(Use several sheets if necessary)		FILING DATE: 10/13/2003	GROUP: 1765

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	ISSUED DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPRO.)
AA	6,319,096	11/20/2001	Mueller et al.			
AB	6,530,826	03/11/2003	Wenski et al.			
AC	6,627,107	09/30/2003	Srinivasan et al.			

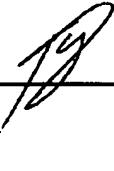
FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
BA	CN1246725	03/08/2000	China			Yes-EP0984049 is a family member
BB	EP0984049	03/08/2000	EPO			

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

CA	Espacenet Family List for CN124675, 10/2/2006				
EXAMINER		DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small>				Docket Number (Optional) FIS9-2002-0214US1		Application Number 10/605,610	
<i>NOV 07 2003</i>				Applicant(s) Delehanty et al.			
				Filing Date 10-13-03		Group Art Unit 	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
	Appl. No. 60/463,358, Attorney Docket No. AMAT/7662L/CMP/CMP/RKK, entitled "Carbonation of pH controlled KOH solution for improved polishing of oxide films on semiconductor wafers" <i>(no date)</i>						
EXAMINER				DATE CONSIDERED			
<i>BS</i>				<i>1-Aug-05</i>			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

**Form PTO-A820
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